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| FORM PTO-1449 (MODIFIED) | ATTORNEY DOCKET NO. | SERIAL NO. |
| LIST OF PATENTS AND PUBLICATIONS FOR APPLICANTS INFORMATION DISCLOSURE STATEMENT | SP01-273 | TBA |
| | APPLICANT Fewkes et al. | |
| | FILING DATE TBA | GROUP: TBA |

10/08/01
03/01/02

| REFERENCE DESIGNATION | | U.S. PATENT DOCUMENTS | | | | | |
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| Examiner Initial | | Document Number | Date | Name | Class | Sub-Class | Filing Date if Approp. |
| SML | AA | 4,133,731 | 1/9/79 | Hansen et al. | 204 | 159.17 | |
| | AB | 4,851,165 | 7/25/89 | Rennell, Jr. et al. | 264 | 1.5 | |
| | AC | 5,179,171 | 1/12/93 | Minami et al. | 525 | 288 | |
| | AD | 5,268,984 | 12/7/93 | Hosoya et al. | 385 | 128 | |
| | AE | 5,286,682 | 2/15/94 | Jacobs et al. | 501 | 34 | |
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| | AK | 5,654,386 | 8/5/97 | Minami et al. | 526 | 281 | |
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| | AM | 5,747,551 | 5/5/98 | Lewandowski et al. | 522 | 95 | |
| | AN | 5,981,064 | 11/9/99 | Burack et al. | 428 | 375 | |
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| | AP | 6,054,217 | 4/25/00 | Szum et al. | 428 | 392 | |

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| | | Document Number | Date | Country | Class | Sub-Class | Translation | |
| | | | | | | | Yes | No |
| SML | AQ | WO 99/27405 | 6/3/99 | WO | G02B | 6/44 | X | |
| SML | AR | WO 00/66636 | 11/9/00 | WO | C08F | 2/48 | X | |

| OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.) | | |
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| SML | AS | "Adhesives, 2. Theories of Adhesion", Alphonsus V. Pocius, The 3M Company, Kirk-Othmer Encyclopedia of Chemical Technology, 1991 |
| | AT | "Adhesives, 6. Chemistry and Uses of Adhesives", Alphonsus V. Pocius, The 3M Company, Kirk-Othmer Encyclopedia of Chemical Technology, 1991 |
| | AU | "Development of a Simplified Relationship Between Uniaxial Creep, Stress Relaxation, and Constant Strain-Rate Results for Viscoelastic Polymeric Materials", Richard D. Sudduth, Journal of Applied Polymer Science, Vol. 82, pg. 527-540, 2001 |
| | AV | "Viscoelastic Window of Pressure-Sensitive Adhesives" E.P. Chang, J. Adhesion, 1991, Vol. 34, pg. 189-200, 1999 |
| SML | AW | "Handbook of Pressure Sensitive Adhesive Technology" Third Edition, Donatas Satas, 1989, pg. 171-184 |

Information Disclosure Statement-PTO-1449 (Modified)

John M. Little

9/20/03

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| SML | AX | "An Overview of Ultraviolet Light Curable Pressure Sensitive Adhesives, PSAs", Mark Miltry et al., 2000 TAPPI Hot Melt Symposium, pg. 37-48 |
| | AY | "UV Curable PSAs", Deborah A. Sciangola, Adhesives Age, February 2000, pg. 25-31 |
| SML | AZ | "UV Curable Pressure Sensitive Adhesives" Craig A. Glotfelter, Polymeric Materials Science and Engineering, Volume 72, Spring Meeting 1995, Anaheim California, Proceedings of the American Chemical Society Division of Polymeric Materials: Science and Engineering, pg. 587-588 |

EXAMINER: *S. M. Miller*

DATE CONSIDERED: *9/26/03*

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.